

Notification of Compliance Status National Emission Standards for Hazardous Air Pollutants For Paint and Allied Products Area Sources 40 CFR Part 63 Subpart CCCCCCC

1.	Company	Information:

1. Company information.				
Legal Name:		Facility name (i	if different t	han legal name):
Mailing address:		Facility address	s (if differen	t than mailing address):
City, state, zip code:		City, state, zip code:		
Source category/NAICS cod	e:	Source ID:		
2. Site Contact Person:				
Name:		Telephone number:		
Title:		Email address:		
3. Appropriate compliance date and notification of compliance status due dates for the facility:				
Type of Affected Source	Compliance I	Date	Γ	Date NOCS is Due
Existing Source	December 3, 2012		June 3, 2013	
New Source	New affected sources that started up on or before December 3, 2009: December 3, 2009		New affected sources that started up on or before December 3, 2009: June 1, 2010	
	New affected sources that started up after December 3, 2009: Upon startup of affected source Specify startup date:		New affected sources that started up after December 3, 2009: 180 days after startup of affected source	
	Specify startup date:		source	
4. HAP emissions (report specified in the standards)	ed in units and averaging	times and in a	l	with the test methods

HAP	Emissions	Units	Averaging Times

5. Affected emission sources and compliance approaches: Operate capture system and route particulate emissions to particulate control device that minimizes fugitive Addition of dry pigments and solids containing emissions. metal HAPs to process vessel Control device type ____ (wet or dry). Add pigments and other solids in paste slurry or other liquid form Operate capture system and route particulate emissions to particulate control device that minimizes fugitive Addition of dry pigments and solids containing emissions. metal HAPs to grinding and milling process Control device type _ _ (wet or dry). Add pigments and other solids in paste slurry or other liquid form. Operate capture system and route particulate emissions to particulate control device that minimizes fugitive emissions. Grinding and milling of materials containing metal Control device type ____ (wet or dry). **HAPs** Fully enclose the grinding and milling equipment. Ensure that pigments and solids are in the solution during grinding and milling. Equip with cover or lid that: does not Process and storage vessels that store or process materials containing benzene or methylene warp or move around during the chloride manufacturing process; maintains contact along at least 90-percent of the vessel rim; and that is maintained in good condition. Equip with cover that completely covers Mixing vessels that store or process materials the vessel, except as necessary to allow containing benzene or methylene chloride for safe clearance of the mixer shaft. Leaks and spills of materials containing benzene or Minimize and clean up as soon as methylene chloride practical, but no longer than 1 hour from the time of detection. Keep in a closed container that may Rags or other material containing benzene or methylene chloride contain a device that allows pressure relief, but does not allow liquid solvent to drain from the container.

6. If complying with the NESHAP using a particulate control device, include the information related to the initial control device inspections and tests.

Emission Source	Control Device	Water Flow Verified (Wet Scrubbers Only)	Ductwork/Control Device Inspected	Visible Emission Test Performed	Emissions < 10% Opacity

7. Compliance Certification

I certify that to the best of my knowledge my facility has complied with all the relevant standards and other requirements of 40 CFR Part 63 Subpart CCCCCCC.

Signature:	Date:	
Name:	Telephone Number:	
Title:	Email Address:	